Evaluation of Robustness against External Vibrations for Long-range MEMS Lidar with 1D resonant micromirror

Han Woong Yoo\textsuperscript{a,}\textsuperscript{*}, David Brunner\textsuperscript{a,b}, Matthias Macho\textsuperscript{a}, Leonhard Niedermueller\textsuperscript{b}, Angel Jurado Devesa\textsuperscript{b}, Leonhard Kormann\textsuperscript{b}, Georg Schitter\textsuperscript{a}

\textsuperscript{a}TU Wien, Automation and Control Institute (ACIN), Gusshausstrasse 27-29, 1040 Vienna, Austria
\textsuperscript{b}Infineon Technologies Austria AG, Babenbergerstrasse 10, 8020 Graz, Austria

Abstract. This paper describes the verification of a long-range 1D scanning MEMS lidar specifically considering the robustness against external vibration influences. The 1D scanning MEMS lidar exploits a multichannel horizontal line laser to scan the scene vertically for a 10°×11° horizontal and vertical field of view at a frame rate of up to 29 Hz. To evaluate the robustness against vibrations, a vibration evaluation setup is developed to apply a wideband vibration based on the automotive standard LV124. The vibration tests are performed in three conditions of open loop without a control, and two PLLs with default and high gain settings. The test results demonstrate that vibration can cause wobbly distortion along the scan angle in the open loop case and the PLLs can suppress effectively this influence in the mean and standard deviation of the standard point to surface error up to 69.3 % and 90.0 %, respectively. This verifies the benefits of the MEMS mirror control, ensuring stable point cloud measurements under vibrations in harsh automotive environments.

Keywords: MEMS, lidar, automotive, vibration, robustness.

*Han Woong Yoo, yoo@acin.tuwien.ac.at

1 Introduction

Advancements of sensor technologies and artificial intelligence are about to bring a revolutionary changes in mobility and transportation by autonomous driving.\textsuperscript{1} Lidar is regarded as one of the key sensor technologies that enables a reliable perception of surroundings, especially providing high resolution and long distance 3D object detection in various road situations,\textsuperscript{2} for example a dropped black tire on a highway at more than 100 m away.\textsuperscript{3} To be adopted in most vehicles as standard safety equipment akin to airbags, the unit price of the lidar has to be reduced significantly while its reliability and the lidar lifetime should be improved like the entire car lifetime, which requires fundamental changes in the lidar design and its main components. For high resolution and long-range lidars, a beam scanning systems are essential to deliver sufficient laser power to the scene while keeping the eye safety.\textsuperscript{4}
Scanning mirrors based on Micro-Electro-Mechanical Systems (MEMS) technologies are one of the promising solutions for long-range scanning lidars,\textsuperscript{[5–14]} thanks to a small form factor, high scanning frequencies with a wide field of view, long lifetime, and competitive unit cost in mass production. By scanning methods, the MEMS scanning lidars can be categorized in omniscan,\textsuperscript{6} raster scan,\textsuperscript{5,8,11} Lissajous scan,\textsuperscript{14} and 1D line scan.\textsuperscript{3,4,9} Compared to the other scanning methods, 1D scan lidar is a hybrid of the flash lidar and 2D point scanning lidar, allowing a high frame rate with fewer numbers of laser pulses and less complexity in sensor readout. However, the generation of a uniform laser line is not trivial with commercially available laser arrays. In addition, high laser power is still required due to broadening of the laser into a line along one axis. This limits the detection range since the light sources must comply with class 1 laser specification.

Moreover, MEMS scanning systems for the use in automotive applications have to be highly robust against harsh environmental conditions such as vibrations, shocks, and temperature variations.\textsuperscript{14,15} The vibration and shock influence on MEMS scanning mirrors has been investigated for electrostatic actuation,\textsuperscript{11,16–18} electromagnetic actuation,\textsuperscript{19} and piezoelectric actuation.\textsuperscript{20} Vibration influences during scanning operations is evaluated in,\textsuperscript{16–19} where considerable performance improvements by the designed controllers have been shown. For a parametrically driven resonant MEMS mirror with a reinforcement structure, a large vibration influence is observed by translational vibrations along the direction of the scanning and in the vicinity of the mirror frequency.\textsuperscript{16} This observation suggests to design the resonance frequency above 2 k\text{Hz} considering the vibration spectrum profile of the automotive standard, e.g. LV124,\textsuperscript{21} which does not specify broad-band vibration criteria above this threshold. A PLL used for controlling the mirror also shows an improved robustness against vibration by reducing the peak errors to its half and the robustness also depends on the gain choice of the PLL.\textsuperscript{16,17} A more detailed analysis of the dynamics is discussed for time.
normalized PI PLL design in Ref. 22. The evaluation of MEMS scanning lidar measurements under external vibrations, however, has not been reported so far.

The main contribution of this paper is the evaluation of vibration influences in point cloud measurements of a long-range 1D scanning MEMS lidar. The used long-range MEMS lidar can detect a low reflectance target at 130 m under the bright daylight while it has a narrow field of view (FoV) of $10^\circ \times 11^\circ$ and equips a MEMS control ASIC with a PLL for a resonant MEMS mirror to ensure stable and robust operation. A vibration test setup is developed for the lidar by subjecting the transmitter module to vibrations. Using the vibration test setup, the benefits of the PLL for resonant MEMS mirrors are verified under a wideband vibration based on the automotive standard LV124, demonstrating stable point cloud measurements for an indoor and an outdoor scenes by two quality measures.

The rest of the paper is organized as follows. Section 2 describes the long-range 1D MEMS lidar and the MEMS control ASIC used in this paper. The vibration test setup is illustrated in Section 3 to test the vibration influence on the lidar measurements. In Section 4, experimental results of lidar measurements are discussed for robustness against external vibrations according to different MEMS control conditions. Finally, Section 5 concludes with a summary of the outcome of the paper.

2 Long-range 1D Scanning MEMS Lidar

Figure 1 illustrates a long-range 1D scanning MEMS lidar and its schematics of the components inside. The lidar is designed for long-range detection by reducing its FoV, where the horizontal and vertical FoV are set to $10^\circ$ and $11^\circ$, respectively, allowing a detection of the use case scenario “tire on the road”, e.g. a 10 % of low reflectivity target at 130 m distance outdoor in bright...
The lidar has three main function blocks, i.e. transmitter, receiver and lidar controller. The transmitter block includes the laser module, transmitter optics, and a MEMS scanning system including a MEMS scanning mirror and its driver ASIC. The receiver block consists of receiver optics, the APD array, and receiver ASICs, which process multiple channels of the APD readouts. The lidar controller has been implemented in an FPGA and a microcontroller. The digital system in the FPGA includes the control of the laser pulse timing according to the mirror movements, time of flight calculation based on the receiver signal and functional safety to ensure safe operation of the lidar, especially eye safety. The microcontroller has multiple cores inside, which are used...
Figure 2 describes the block diagram of the resonant MEMS mirror and the MEMS driver ASIC with the FPGA and the microcontroller in the lidar controller. For operation in a positive phase, the mirror operates with an optical scanning angle of ±16.5° while the scanning angle is scaled by 1/3 for designed FoV via an optical system after the MEMS mirror, also allowing a sharp optical resolution in the vertical axis. Since the optical resolution is mainly determined by the size of the mirror, this scan range scaling can be also regarded as a relaxation of a small mirror size. The resonant MEMS mirror used in the lidar is a variant of the MEMS mirrors in Ref. 9, 16, and 24. The MEMS mirror has an elliptical shape with a long axis of 2.7 mm and actuated by out-of-plane electrostatic comb drives. The mirror features leaf springs that exhibit stiffening as the amplitude increases and also has a reinforcement structure, allowing a flat mirror surface at a high frequency operation. The design concepts are discussed in detail in Ref. 24. The variant MEMS mirror design in the lidar improves long term reliability for large operating amplitudes.
while resulting in a reduction of the resonant frequency. This cannot maintain the robustness condition of the resonant frequency over 2 kHz in Ref. 16, i.e. external vibrations defined in an automotive standard LV124 may threat the reliable performance of the lidar measurements.

To ensure the stable and robust operation of the MEMS scanning motion, a MEMS driver ASIC is used.9,25 The MEMS driver ASIC mainly consists of a mirror position sensor, a phase locked loop (PLL) with an amplitude control, and a high voltage (HV) driver. The mirror position sensor detects the zero crossing of the MEMS mirror and specific angle points from the displacement currents of the MEMS mirror stators $i_s$. Based on the mirror position measurements, the PLL calculates the errors of the amplitudes as well as the phase, and regulates the mirror dynamics to provide a stable operation of the scanning frequency and amplitudes of the MEMS mirror. The PLL control is implemented digitally by the timing regulation,22,25 and PI controllers are implemented for both phase and amplitude control, determining the driving signal of the MEMS mirror. This driving signal is amplified by the HV driver and applied to the rotor of the MEMS mirror. Further details about the MEMS driver ASIC design can be found in Ref. 25.

For the lidar operation, the MEMS driver ASIC provides the states of the MEMS mirror such as the mirror position information including scanning direction and amplitude. Based on the mirror state information and the prior knowledge of the scanning trajectory, the laser control module in the FPGA generates short laser pulse signals at scheduled angles of the MEMS mirror. The channels of the laser module are scheduled for the illumination of the scene while keeping a high frame rate and laser class 1 operation. Thanks to the high scanning frequency than the frame rate, the laser lines can be scheduled in a non-continuous manner, providing more margin for laser safety. For the startup sequence, configuration, and monitoring of the MEMS scanning system, the microcontroller can access specific registers in the MEMS driver ASIC via the FPGA. This
3 Vibration Test Setup

Fig. 3a illustrates the vibration test setup for the 1D scanning MEMS lidar. A shaker (TV 51110-126 M, Tira GmbH, Schalkau, Germany) induces the vibration to the transmitter module, which con-127 tains laser module and transmission optics as well as the MEMS mirror. The applied vibration is128 measured by a laser Doppler vibrometer (OFV 534 with OFV 5000, Polytec GmbH, Waldbronn,129 Germany) for the regulation of the applied vibrations. The receiver and the lidar controller are130 fixed next to the transmitter. Only the transmitter is installed on the shaker due to a limited force131 to accelerate the mass for vibration tests. This is still valid setting because the transmitter is more132 sensitive to the vibration by the influence to the MEMS mirror dynamics than the receiver with133 fixed imaging optics and the APD array. Especially translational vibrations along the vertical axis134 would not influence the receiver much due to the long rectangular pixels along that vibration di-135 Fig 3  a) Vibration test setup for the 1D scanning MEMS lidar. b) power spectral density of the applied vibration, measured by laser Doppler vibrometer (LDV)

Fig 3 a) Vibration test setup for the 1D scanning MEMS lidar. b) power spectral density of the applied vibration, measured by laser Doppler vibrometer (LDV)
Fig 4  a) Picture of the indoor test scene, b) angle-radial distance map of the indoor scene and 5 RoIs of the scene for quantitative evaluation, c) point cloud of the indoor scene in perspective view, d) point cloud in a view along the distance.

The vibration is along the vertical scan direction while the mirror is tilted to the vibration about 70° as in Fig. 3a. Since the mirror scanning frequency is 1792 Hz and the vibration influence is high near the scanning frequency, a wideband random vibration with a bandwidth from 1 to 2 kHz is considered for the evaluation of vibration influences, which is with a constant power spectral density of 0.14 (m/s²)²/Hz as shown in Fig. 3b, corresponding to the total RMS acceleration of 11.8 m/s. This vibration profile is the high frequency part of the vibration profile D (total RMS acceleration 30.8 m/s) for hang-on parts on sprung masses in the automotive standard of LV124.

4 Experimental Evaluation of Robustness against Vibrations

To evaluate the vibration influences to the 1D scanning MEMS lidar measurements, an indoor and an outdoor scene is considered. Fig. 4a illustrates the indoor scene of the corridor with several features for the test such as a sharp target, a bumpy floor and various surfaces of the walls, the floor.
a) Picture of the outdoor test scene, b) angle-radial distance map of the outdoor scene, c) a point cloud of the outdoor scene in perspective view, d) point cloud in a view along the distance

and the ceil. The lidar measures the radial distance by ToF measurements as shown in Fig. 4b. Then the point cloud is generated by the combination of the radial distances, the scanning position and the pixel location at the detector, shown in Fig. 4c. Fig. 4d illustrates the major features along the distance. It is readily observed that some points are below the floor or above the ceil mainly due to the specular reflection with the shallow incident angle by the floor or the ceil, respectively.

Fig. 5a depicts an outdoor scene, a small facade and a rooftop of a building at a distance over 30 m. The angle-radial distance map and point cloud generation can be drawn with the same manner. The far distance objects around 93 m are leaves of the tree, shown above the rooftop.

For evaluation, three control conditions are considered, i.e. an open loop without a control, a PLL control, and a PLL control with a high gain. The open loop case disables the PLL, and the PLL control case exploits the default low gain of the MEMS driver ASIC, which is chosen for a stable operation of the mirror and EMI influence. For the PLL with a high gain case, all gains are increased more than two times higher than the default value. Fig. 6 illustrates angle-radial distance maps and the point clouds under the wideband vibrations for three control conditions. The video
shows that the pixels of the radial distance are not properly measured due to the scanning position errors induced by the vibration, leading to wobbly point clouds in the open loop case. The wobbly point cloud movements are effectively suppressed by both the PLL and the PLL with high gain, which is comparable with the vibration free case.

To evaluate this robustness performance quantitatively, quality measures are applied for point clouds at 5 region of interest (RoI), shown in Fig. 7b. First of all, the RoI #1, #2, #3 and #4 represent specific planes in the scene. The RoI #1 corresponds to a plane of the ceil where radian distance varies along the vertical direction. On the contrary, the RoI #2 represents a plane where the radial distance varies along the horizontal direction. The RoI #3 is a plane almost perpendicular to the radial direction and RoI #4 is similar with RoI #1 but with a nonlinear plane with a curvature.
For RoI #1 to #4, a standard error of point to surface in an area A is given by

\[
E_{p2s,A} = \sqrt{\frac{1}{N_A} \sum_{i,j \in A} (\hat{e}_{i,j} \cdot \hat{n}_A)^2},
\]

(1)

where \(\hat{e}_{i,j}\) denotes the error vector of the horizontal and vertical pixel index of \(i\) and \(j\), respectively, and \(\hat{n}_A\) is the normal vector of the surface A, estimated by \textit{pclkfitspplane} in Matlab.\(^{27}\) The error vector is calculated based on the mean radial distance of the vibration free scene for each control conditions. \(N_A\) denotes the number of pixels in the area. The square root makes the error in the unit of the distance, e.g. mm. This point to surface error represents the perceived quality in the surfaces structured scene while the errors tend to decrease for the surfaces with high angle to the radial direction considering the dominant radial distance errors in the lidar measurements. For the case of the sharp bar target with 20 mm thickness in RoI #5, a RMS thickness of the bar is proposed as a quality measure,

\[
T_{bar} = \sqrt{\frac{1}{N_{bar}} \sum_{i,j \in A_{bar}} (y_{i,j} - y_c)^2},
\]

(2)

where \(y_{i,j}\) denotes a vertical position of the detected pixels of the bar and \(y_c\) is the center position of the bar in the measurements. \(N_{bar}\) denotes the number of pixels on the bar in the area \(A_{bar}\). This RMS thickness measures the deviation of the pixel position of the thin bar shape.

Fig. 7 describes box plots of the standard point to surface errors and the RMS thickness for the RoIs for 300 frames. Under the wideband vibration and in the open loop case, large error increases can be measured in RoI #1 and #4 where the plane varies the radial distance by the scanning axis. For the surface of RoI #2 that varies the radial distance only orthogonal to the scan axis and the perpendicular surface of RoI #3 shows less sensitivity to the vibration. Both the PLL and the PLL...
with high gain can slightly increase errors in some cases without vibrations mainly due to feedback of the sensor noise, but demonstrate improved errors under the vibration by reducing its mean value up to 69.3 % and its standard deviation up to 90.0 %. The PLL with a high gain shows a better performance for ROI #1 and #4 than the PLL with the default low gain. The standard deviation of the RMS thickness in the open loop case increases 12.8 times larger after the vibration is applied while the PLL with high gain reduces it up to 67.4 %. These results prove that a PLL control design for MEMS mirrors can improve the robustness against external vibrations, enabling stable point cloud measurements with a 1D scanning MEMS lidar even under vibrations on the scanning frequency of the MEMS mirror.
5 Conclusion

This paper discusses robustness against external vibrations for a long-range 1D scanning MEMS lidar. The 1D scanning MEMS lidar provides $10^\circ$ and $11^\circ$ of horizontal and vertical FoV, respectively, at 29 frames per second by scanning horizontal laser lines along the vertical axis. The MEMS mirror used in the lidar has improved long term reliability but with reduced scanning frequency below 2 kHz, leading to a concern of the qualification against vibrations in an automotive standard LV124. A MEMS driver ASIC in the lidar includes a PLL with an amplitude control to ensure the stable and robust operation of the MEMS mirror. A vibration test setup is developed for applying a wideband vibration based on LV124 to the transmitter module of the 1D scanning MEMS lidar, which is expected to have high sensitivity to the external vibration. For vibration tests, the control conditions of an open loop without a control and PLLs with two different gains are evaluated for both indoor and outdoor scenes. The measured point clouds demonstrate that the PLL in the MEMS driver ASIC can suppress the vibration influence well for the worst ROI in the scene, reducing the mean and standard deviation of the standard point to surface errors up to 69.3 % and 90.0 % compared to the open loop case, respectively. The videos under the wideband vibration also show the stable point cloud with the PLL, proving the benefits of the control for MEMS mirror used in automotive qualified MEMS lidars to achieve high robustness against external vibrations.

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Disclosures

The authors declare no conflicts of interest.

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Data, Materials, and Code Availability

No data were generated or analyzed in the presented research.

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Han Woong Yoo is postdoctoral researcher in Advanced Mechatronic Systems at the Automation
and Control Institute (ACIN) of TU Wien. He received BSc from Yonsei University and MSc from Seoul National University, and PhD from Delft University of Technology in 2005, 2007 and 2015, respectively. He worked in Samsung Advanced Institute of Technology and Samsung Electronics co. LTD for digital RF and multi-level nonvolatile memories. His main research interests are optical metrology, precision mechatronics systems, and biomedical imaging.

David Brunner is PhD student in Advanced Mechatronic Systems at the Automation and Control Institute (ACIN) of TU Wien and currently working on MEMS based laser beam scanning at Infineon Technologies Austria AG. He received his MSc degree in Energy Systems and Automation Technology from TU Wien, Austria, in 2017. His primary interests include advanced identification and control concepts, high performance mechatronic systems and system integration.

Matthias Macho is master student at the Automation and Control Institute (ACIN) of TU Wien. He received his BSc degree in Energy Systems and Automation Technology from TU Wien, Austria, in 2019. His current interest is control concepts for MEMS mirrors.

Leonhard Niedermueller is verification engineer of the Component Verification group at Infineon Technologies Austria AG in Graz, Austria. He studied at the Technical University Graz. His current research interests are Micro-Electro-Mechanical-Systems (MEMS) and their different possible applications as sensors, like pressure, gas and the application of optical beam steering with MEMS.

Angel Jurado Devesa is concept engineer at Infineon Technologies Austria AG in Graz, Austria and PhD student at Technical University of Graz. He received his BS in Electronic and Automatic Industrial Engineering at Universidad de Alcalá de Henares, Spain, and MS in FH Joanneum.
Leonhard Kormann is principal engineer for Component Verification at Infineon Technologies Austria AG in Graz. He received his BS and MS degrees in Telematics from the Technical University of Graz 2003 and 2005. His current research interests include high performance optical scan systems, optical metrology and projection technology.

Georg Schitter is professor for Advanced Mechatronic Systems at the Automation and Control Institute (ACIN) of TU Wien. He received an MSc in Electrical Engineering from TU Graz, Austria (2000) and an MSc and PhD degree from ETH Zurich, Switzerland (2004). His primary research interests are on high-performance mechatronic systems for applications in the high-tech industry, scientific instrumentation, and mechatronic imaging systems, such as AFM, scanning laser and LIDAR systems, telescope systems, adaptive optics, and lithography systems.

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